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OFFICIAL

MI22-1544

Application Serial No. 09/677,478
Response to March 16, 2004 OA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/677,478
 Filing Date October 2, 2000
 Inventor Guy T. Blalock
 Assignee Micron Technology, Inc.
 Group Art Unit 1765
 Examiner Lan Vinh
 Attorney's Docket No. MI22-1544
 Title: Plasma Etching Methods

RESPONSE TO MARCH 16, 2004 OFFICE ACTION

To: Mail Stop Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

From: D. Brent Kenady
 Tel. 509-624-4276; Fax 509-838-3424
 Wells St. John P.S.
 601 W. First Avenue, Suite 1300
 Spokane, WA 99201-3828

all processed

Responsive to the Office Action dated March 16, 2004, Applicant
 amends and remarks as follows:

AMENDMENTS

Underlines indicate insertions and strikeouts indicate deletions.